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PATENT  
5018/ISM/MCVD/BG  
7828.7056

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of ) Examiner: not assigned  
Tepman, et al. )  
Serial No.: 10/074,854 ) Art Unit: 2812  
Filed: February 11, 2002 )  
For: VARIABLE FLOW DEPOSITION APPARATUS AND METHOD IN  
SEMICONDUCTOR SUBSTRATE PROCESSING

PETITION FOR EXTENSION OF TIME

Assistant Commissioner of Patents  
Washington, D.C. 20231

Dear Sir:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the formalities letter mailed March 11, 2002 in the above-identified application. The requested period of extension is two months, from May 11, 2002 to July 11, 2002.

A check in the amount of \$400 to cover the extension fee is enclosed. The Commissioner is authorized to charge any additional fees which may be required, or to credit any overpayment, to Deposit Account 50-0585. A copy of this letter is enclosed.

Respectfully submitted,

William K. Konrad, Reg. No. 28,868  
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(Date) 7/9/02

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail on the date indicated above and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

William K. Konrad

Date

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